INSTRUMENTATION

- A "Taste" of ILC Beam Instrumentation -

Manfred Wendt Fermilab



Contents



Introduction

- ILC beam parameters, again
- ILC beam instrumentation needs and requirements
- Basic electro-magnetic (EM) beam monitors
 - Image currents and beam current monitoring
 - Broadband beam position monitors
- Optical and other advanced beam monitors
 - Resonant beam monitors (cavity BPM, HOM instrumentation)
 - Various examples of beam monitors using transition radiation
 - Longitudinal bunch profile instruments (DMC & EOS)
 - Bunch arrival / beam phase monitoring
 - LASER wire scanner
- Final remarks



Introduction: Scope



This lecture IS NOT:

- A systematic teaching introduction into the field of beam instrumentation
- You will NOT hear a comprehensive overview on all ILC beam instruments and diagnostics

However, the next 40 min. will entertain you with A "taste" of ILC beam instrumentation

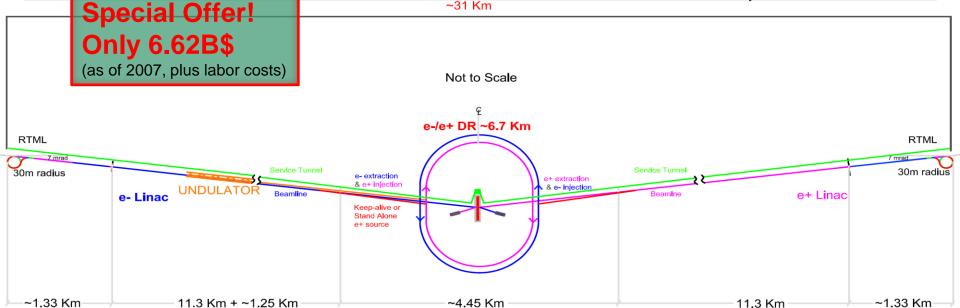
- Many examples of ILC beam monitors, and related R&D
- Principle of function with no/minimum theory
- Outline specific instrumentation problems
- Motivate YOU to become part of the team! | manfred@fnal.gov



Intro: ILC Beam Parameters



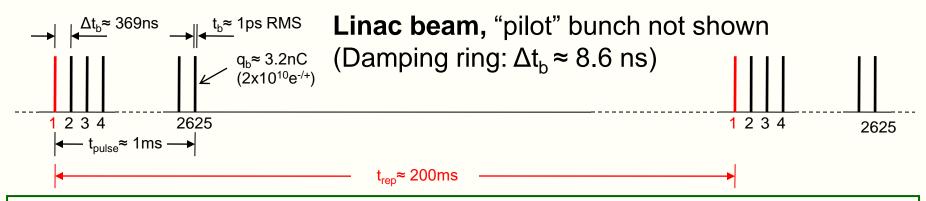
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Beam Parameters:
                                                                      2 x 250 GeV
                                                                                                                           300 µm (187 GHz)
                                                beam energy
                                                                                                  bunch length \sigma_{z}
                                                                      2 \times 10^{34}
                                                 luminosity L
                                                                                               vert. emittance \gamma \varepsilon_{v}^{*}
                                                                                                                           0.04 mm mrad
                                           rep. frequency f_{ren}
                                                                      5 Hz
                                                                                               RMS energy spread
                                                                                                                           0.1 %
                                     macro pulse length t_{nulse}
                                                                      969 µs
                                                                                                           \beta_r^*(IP)
                                                                                                                           21 mm
                                                                      2625
                                                                                                           \beta_{v}^{*}(IP) =
                                      # of bunches per pulse
                                                                                                                           0.4 mm
                                           bunch spacing \Delta t_h
                                                                      369 ns (2.2 MHz.)
                                                                                              hor. beamsize (IP) \sigma_r
                                                                                                                           620 nm
                                                                      3.2 nC
                                                                                                                           5.7 nm
                                                bunch charge
                                                                                            vert. beamsize (IP) \sigma_{y}
```



Schematic Layout of the 500 GeV Machine

Intro: Beam Characteristics





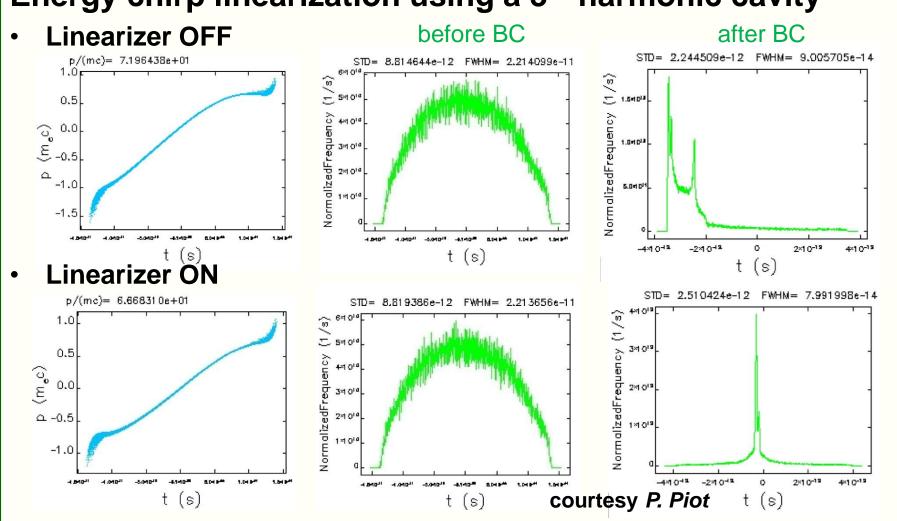
- Charged particle bunches of ~ 2x10¹⁰ e⁻ or e⁺
- "Ribbon" bunch, Gaussian-like profile
 - Along linac sections ~1 μm range vert., ~100 μm range hor.
 - RMS bunch length ~ 300 μm (1 ps)
- Non-linear field effects result in non-Gaussian particle distributions in the bunch
 - e.g. off-crest acceleration, CSR-effects (bunch compressor), wakefields



ilc Intro: Long. Bunch Gymnastics



Energy chirp linearization using a 3rd harmonic cavity





Intro: Beam Diagnostics



- Machine commissioning, error detection
 - Fundamental beam instruments, e.g. beam intensity (bunch charge), beam orbit (BPM), beam profile (screens, wire scanners)
 - Dynamic range, single bunch / single pass signal processing, time stamped data acquisition
 - Beam parameter characterization in each area
- Emittance preservation, luminosity optimization
 - High resolution instrumentation for beam position & energy, trans. and long. beam profile, bunch arrival timing
- Stable machine operation
 - Various slow and fast feedback systems, transverse intra-train
 IP feedback
- Machine protection (11 MW beam power, linac: 20 kW)
 - Beam loss monitor (BLM) system



Intro: ILC Beam Instruments



- ~ 2000 Button/stripline BPM's (10-30 / 0.5 µm resolution)
- ~ 1800 Cavity BPM's (warm, 0.1-0.5 µm resolution)
- 620 Cavity BPM's (cold, part of the cryostat, ~ 1 μm)
- 21 LASER Wirescanners (0.5-5 µm resolution)
- 20 Wirescanners (traditional)
- 15 Deflecting Mode Cavities (bunch length)
- ~ 1600 BLM's

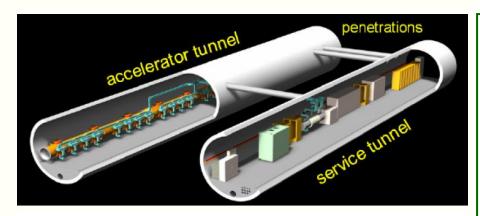
Instrumentation Costs: ~100M\$, plus labor

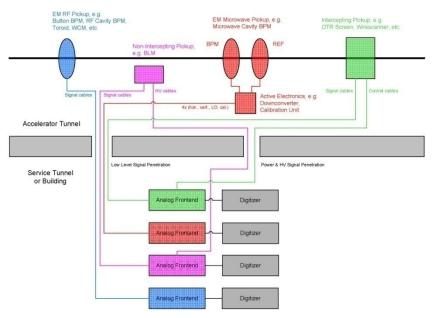
- Other beam monitors, e.g. toroids, bunch arrival / beam phase monitors, wall current monitors, faraday cups, OTR & other screen monitors, sync light monitors, streak cameras, feedback systems, etc.
- Read-out & control electronics for all beam monitors



Intro: Tunnel Hardware







Beam Instruments:

- Intercepting or nonintercepting pickup stations, often part of the beam vacuum system, located in the accelerator tunnel.
- Read-out, control, and data acquisition electronics, located in the service tunnel, wire connections through penetrations.
- Auxiliary system, e.g. racks, crates, PS, timing,...



EM Beam Monitoring

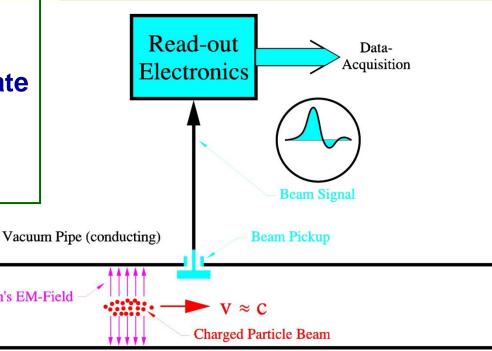


Beam Pickup

- Converts the beam's EM field into a electric signal by use of antenna(s), etc.
- Part of the vacuum system
- ILC: Typically operate in the RF & microwave range

Read-out Electronics

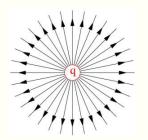
Detects, amplifies, and modifies the signal to extract the wanted beam parameter (often digital signal processing)

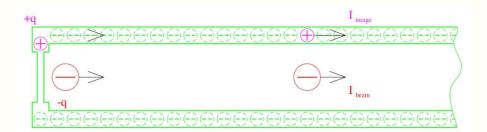


Beam's EM-Field

Image Currents







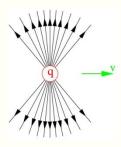
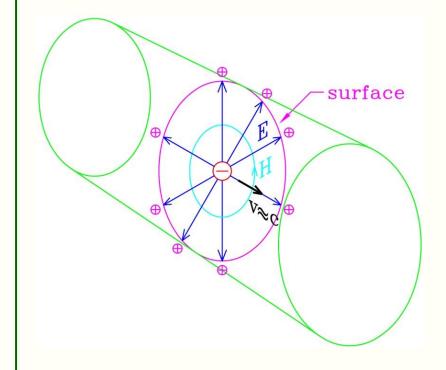


Image currents

- Flow on the inner surface of the conducting vacuum chamber
- Compensate the beam charge
- At v ≈ c have a pancake-like
 TEM field

$$\mathbf{E} = \frac{q}{4\pi\varepsilon_0} \frac{1 - \beta^2}{\left(1 - \beta^2 \sin^2\theta\right)^{3/2}} \frac{\mathbf{r}}{r}$$

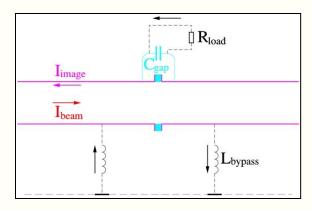
where θ references to the direction of \mathbf{v}

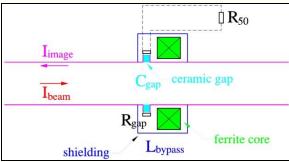


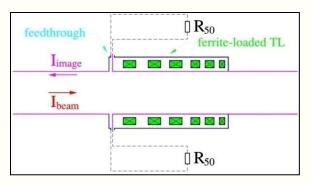


Simple Beam Current Monitors









Single particle (q=e) impulseresponse z(t) : (t) =

$$i_{beam}(t) = q \, \delta(t)$$

$$v_{gap}(t) = -\frac{1}{C_{gap}} \int_{-\infty}^{t} i(\tau) d\tau = -\frac{q}{C_{gap}}$$

$$v_{out}(t) = i_{beam}(t) z(t)$$

Transfer impedance Z(ω) of a beam
 pickup

$$v_{out}(t) = \int_{-\infty}^{t} z(t-\tau) i_{beam}(\tau) d(\tau)$$

$$V_{out}(\omega) = I_{beam}(\omega) Z(\omega)$$

- Wall current monitor response:

$$Z_{WCM}(\omega) = \frac{\frac{1/\omega_{hi}}{R_{load}} R_{load}}{1 + j(\omega R_{load} C_{gap}) - (R_{load} / L_{bypass})\omega}$$



Toroids











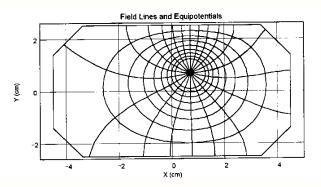
courtesy Bergoz

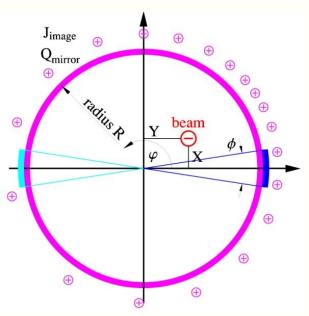
- AC CT (high-pass char. $Z_{ACCT}(\omega) = \frac{j \omega L_s}{(1 + j \omega L_s / R_{load})N_s}$)
 - Ceramic gap, ferrit core, shielding, calibration winding(!)
- DC CT (used in ring accelerators)
 - Coupled CT's with compensation feedback for DC measurements.
- CCC (for dark current measurements)
 - SC current comparator (SQUID-based).



Broadband BPM Pickups







 Fields and image charges of an offcenter beam (circular pipe):

$$J_{image}(X,Y,\varphi) = -\frac{I_{beam}}{2\pi R} \frac{R^2 - (X^2 + Y^2)}{R^2 + X^2 + Y^2 - 2R(X\cos\varphi + Y\sin\varphi)}$$

Ideal pickup electrode (x=X/R, y=Y/R)

$$I_{elec}(x, y, \phi) = -\frac{2I_{beam}}{\pi} \arctan \frac{[(1+x)^2 + y^2]\tan(\phi/4) - 2y}{1 - x^2 - y^2}$$

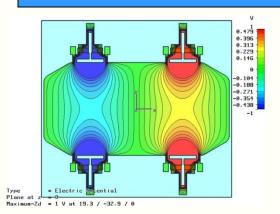
- Beam position monitor (BPM)
 - Symmetric arranged electrodes
 - Common mode signal (I_{beam})
 - Beam intensity normalization (Δ/Σ)
 - Powerful beam instrument (beam orbit, optics, errors, emittance, etc.)

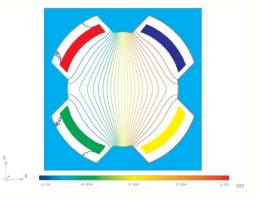
$$V_{elec}(x, y, \omega) = s(x, y) Z(\omega) I_{beam}(\omega)$$

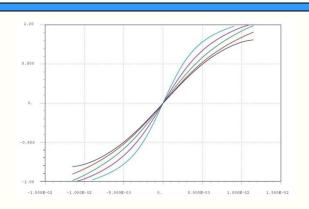


Button & Stripline BPMs

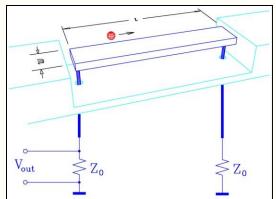


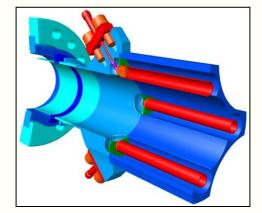


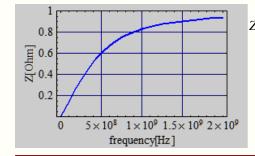






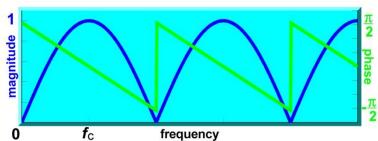






$$Z_{button}(\omega) = Z_0 \frac{r_{button}}{4r_{pipe}} \frac{2r_{button}}{c_0 Z_0 C_{button}} \frac{j\omega Z_0 C_{button}}{1 + j\omega Z_0 C_{button}}$$

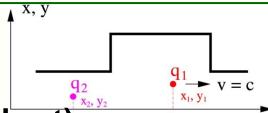
$$Z_{stripline}(\omega) = jZ_0 \exp\left(-j\frac{\omega l}{c_0}\right) \sin\left(\frac{\omega l}{c_0}\right)$$



ilc Wakefields, Wakepotential & HOM



$$\mathbf{F} = \frac{d\mathbf{p}}{dt} = q_2(\mathbf{E} + c_0 e_z \times \mathbf{B})$$

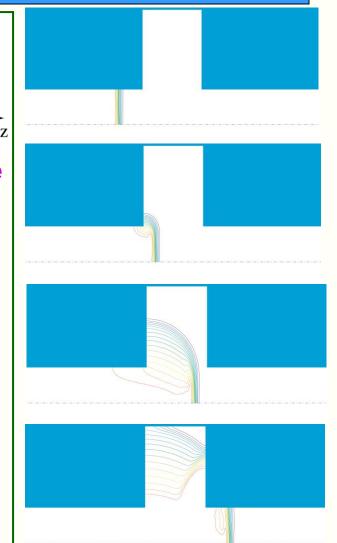


- Wakefields (long, short) s
 - A (point) charge q_1 , acts on a test charge q_2 in presence of discontinuities (here: cavity) with the Lorenz force F.
- Wakepotential:

$$\mathbf{W}(x_2, y_2, x_1, y_2, s) = \frac{1}{q_1} \int_{0}^{L} dz (\mathbf{E} + c_0 e_z \times \mathbf{B})_{t=(z+s)/c_0}$$

- Long. trans.: Panofski-Wenzel
- **Higher order modes (HOM):**
 - Multipole expansion for cyl. sym. struct.

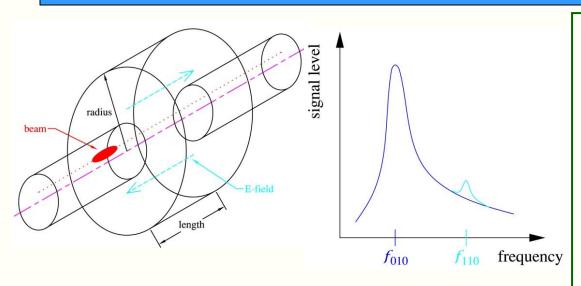
$$W_{\perp}^{(n)}(s) = c_0 \sum_{i} \left(\frac{R^{(n)}}{Q}\right)_{i} \sin\left(\frac{\omega_{i} s}{c_0}\right) \exp\left(\frac{-\omega_{i} s}{2(Q_{ext})_{i} c_0}\right)$$

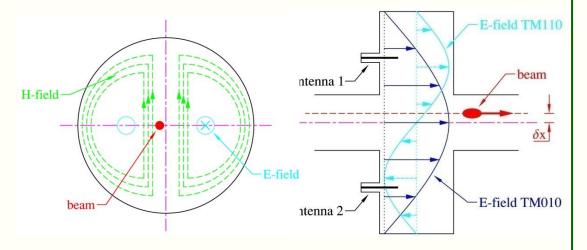




Cavity BPM







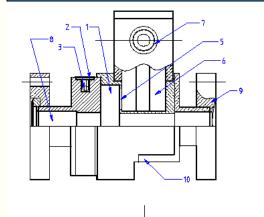
"Pillbox" cavity BPM

- Generates dipole
 (TM₁₁₀) and monopole
 (TM₀₁₀) modes
- Needs common mode (TM₀₁₀) suppression!
- Orthogonal dipole mode polarization (xy cross talk)
- Transient (single bunch) response (Q_L)
- Normalization and phase reference
- Special needs for cryogenic installation



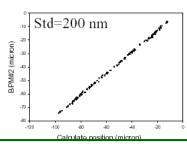
CM-free Cavity BPMs

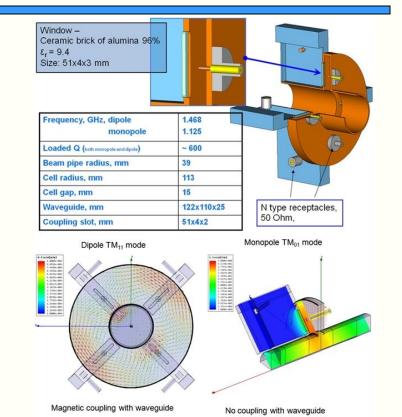




Cross-sectional view of BINP cavity BPM 6426 MHz, (5p. in KEK ATF + 1p.). 2000.

- 1.- Cavity sensor.
- 2- Heater.
- 3 Temperature sensor.
- 5 Coupling slot.
- 6 Output waveguide.
- 7 Output feedthrough.
- 8 Beam pipe.
- 9 Vacuum flange.
- 10 Support plate.
- 11 Y position output.
- 12 X position output.
- 13 Heater control connector.



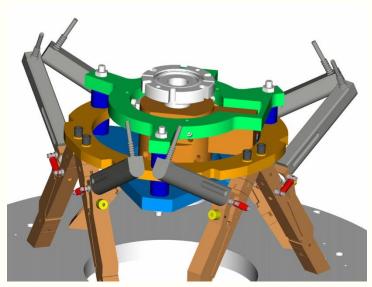


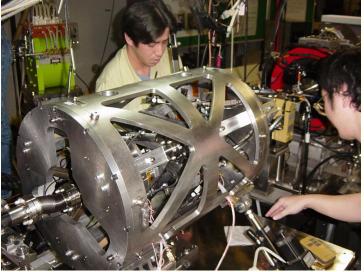
- Uses waveguides to suppress the common modes (slot coupling)
- Resolution <20 nm demonstrated (ATF)
- "Cold" design without reference cavity

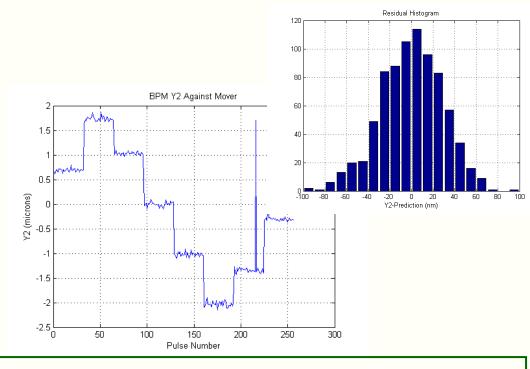












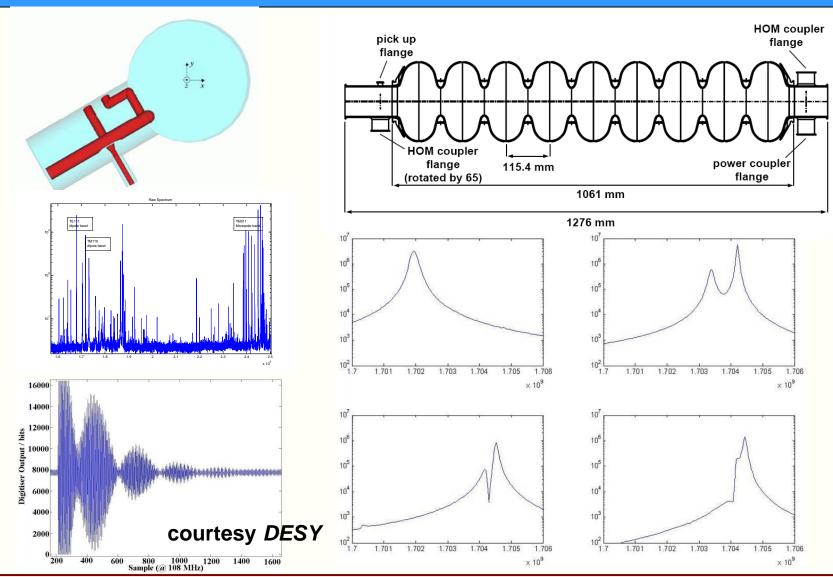
Cavity BPM development (ATF)

- Hexapod and spaceframe (LLNL), alignment in 6 degrees of freedom
- 24 nm (RMS) resolution, dualdownconverter & digitizer



ilc HOM Signals for Beam Monitoring

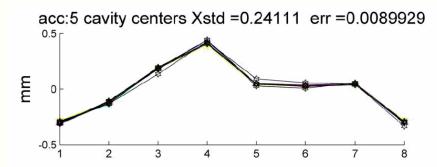


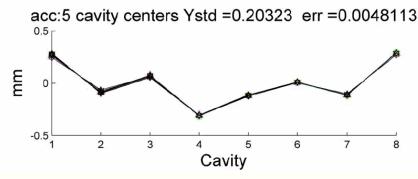


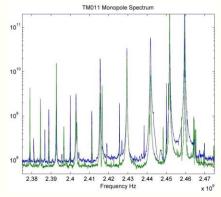


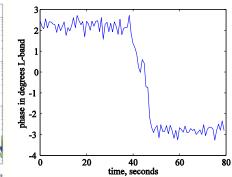
HOM Beam Position & Phase









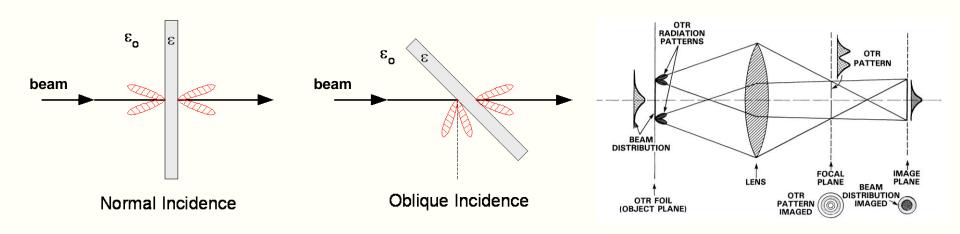


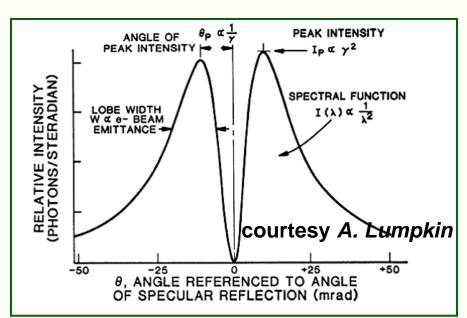
HOM as BPM

- TE₁₁₁₋₆ narrow band read-out
- Beam-based calibration data, to orthogonalize the polarization planes of the excited eigenmodes per SVD algorithm.
- − ~ 5 µm resolution
- HOM as phase monitor
 - Comparison of the leaking
 1.3 GHz fundamental (TM₀₁₀)
 to the first monopole HOM (TM₀₁₁)
 - Broadband Scope analysis
 - <0.1° @ 1.3 GHz resolution</p>

ilc Optical Transition Radiation (OTR)







Transition radiation

$$\frac{d^{2}U}{d\omega d\Omega} \approx I(\omega, \theta) = \frac{e^{2}}{hc_{0}} \frac{1}{\pi^{2}\omega} \frac{\theta^{2}}{(\gamma^{-2} + \theta^{2})^{2}}$$

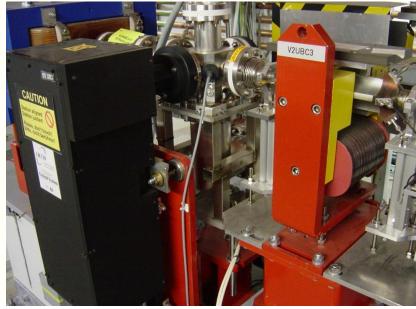
- Charged particles passes through a media boundary
- Monitoring of trans. beam profile (-> emittance), bunch length and energy

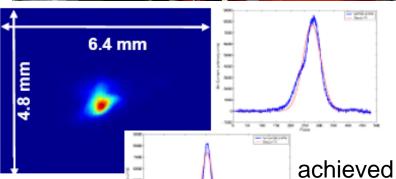


ilc Transverse OTR Beam Monitors









courtesy K. Honkavaara

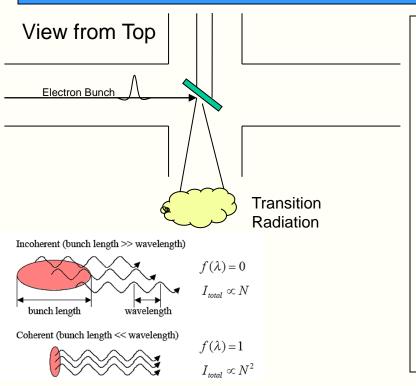
resolution:

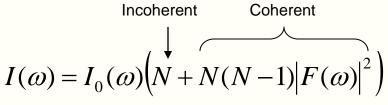
~ 10 µm (RMS)



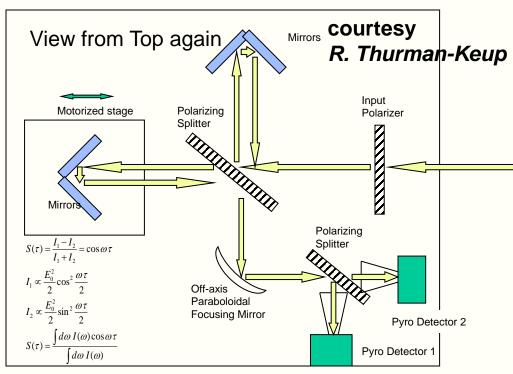
Bunch Length Interferometer







$$F(\omega) = \frac{1}{Q} \int d^3x \rho(\vec{x}) e^{-i\omega(\vec{x}\cdot\hat{n})}$$

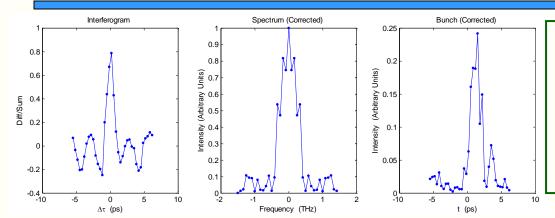


- **Martin-Puplett interferometer**
 - Needs many beam pulses to resolve the temporal convolution
 - Difficult to calibrate the detectors



OTR Interferometers





Detector elements

- Molectron pyro-electric (cheap, calibration)
- Golay cell (expensive)



Martin-Puplett interferometer (courtesy DESY)



Michelson interferometer (courtesy U of Georgia & NIU)



Optical Diffraction Radiation



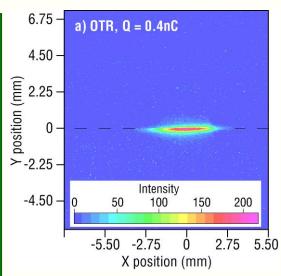
Optical diffraction radiation (ODR):

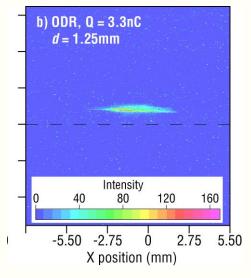
- Near field effect between EM fields of the beam close to a conducting screen Intensity: $2\pi a$

 $I \propto \exp\left(-\frac{2\pi a}{\gamma \lambda}\right)$

- DR impact parameter: $\Rightarrow \frac{\gamma \lambda}{2\pi}$ weak radiation $\frac{\gamma \lambda}{2\pi} \Rightarrow \text{ if } a = \frac{\gamma \lambda}{2\pi}$ DR $<<\frac{\gamma \lambda}{2\pi}$ TR

Non-intercepting beam measurement!





courtesy A. Lumpkin

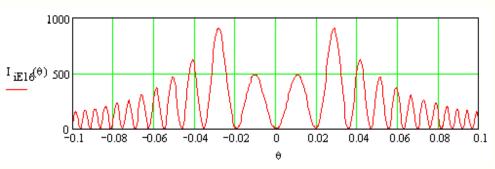


OTR Interferometer





courtesy G. Kazakevich



OTRI:

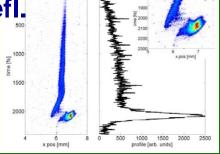
A beam passing two thin foils, allows the measurement of additional beam parameters (energy, energy spread, divergence), derived from the OTR interference pattern.

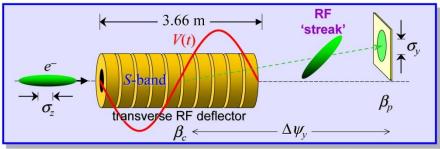


Deflecting Mode Cavity



- DMC, RF streak camera, "LOLA" (SLAC S-Band DMC):
 - Dipole mode cavity, TM₁₁ 2π traveling wave defl.
 - High resolution bunch length measurement
 - Single pass measurement, but intercepting
 - Accurate calibration(!)





$$\sigma_{y} = \sqrt{\sigma_{y0}^{2} + \sigma_{z}^{2} \beta_{c} \beta_{p} \left(\frac{2\pi e V_{0}}{\lambda E_{0}} \sin \Delta \psi_{y} \cos \varphi\right)^{2}}$$

$$\langle \Delta y \rangle = \frac{e V_{0}}{E_{0}} \sqrt{\beta_{c} \beta_{p}} \sin \Delta \psi_{y} \sin \varphi, \qquad V_{0} \approx \left(1.6 \text{ MV/m/MW}^{1/2}\right) L \sqrt{P_{0}}$$

$$\sigma_{z} \approx 25 \ \mu\text{m} \qquad \Delta \psi_{y} \approx 15.8^{\circ}$$

$$E_{0} \approx 0.6 \text{ GeV} \qquad \varphi \approx 0^{\circ}$$

$$(\beta_{c}\beta_{p})^{1/2} \approx 51 \text{ m} \qquad \lambda \approx 105 \text{ mm}$$

$$\gamma \varepsilon_{y} \approx 5 \ \mu\text{m} \qquad \sigma_{y0} \approx 317 \ \mu\text{m}$$

$$L \approx 3.66 \text{ m}, V_{0} \approx 25 \text{ MV},$$

$$P_{0} \approx 18 \text{ MW}$$

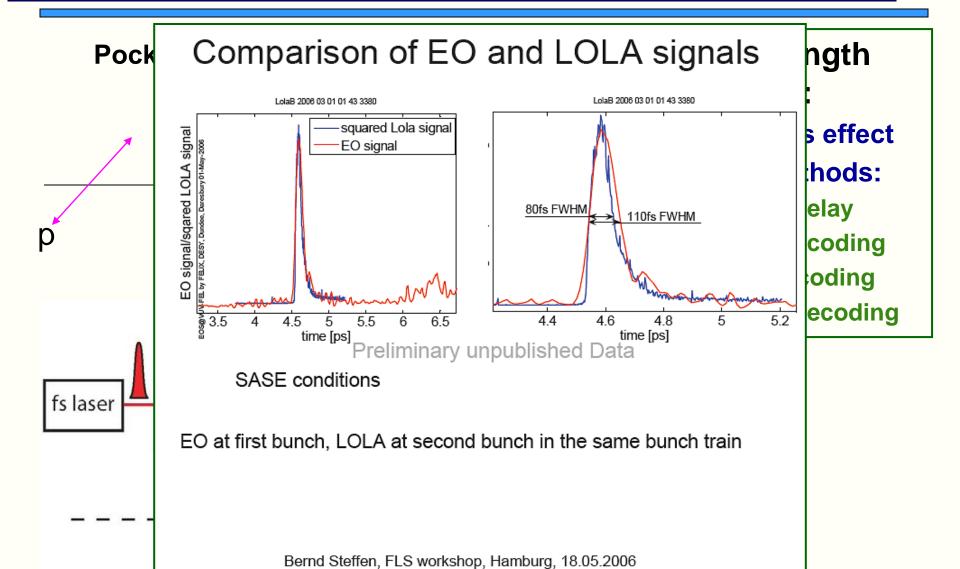
$$\sigma_{y} \approx 925 \ \mu\text{m}$$
P. Emma (SLAC)





Electro-Optical Sampling (EOS)

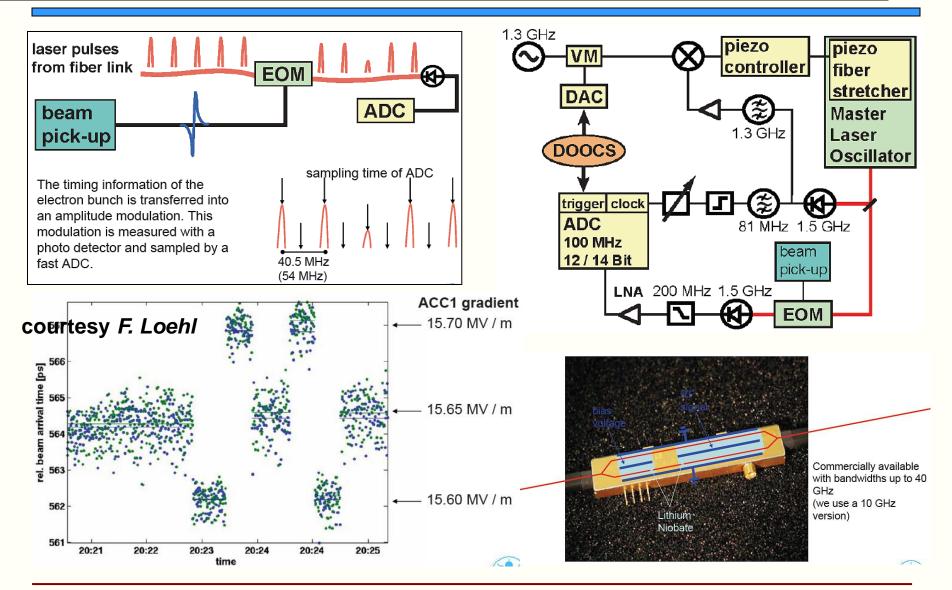






Bunch Arrival / Beam Phase





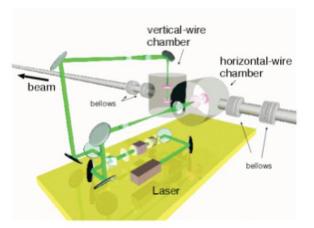


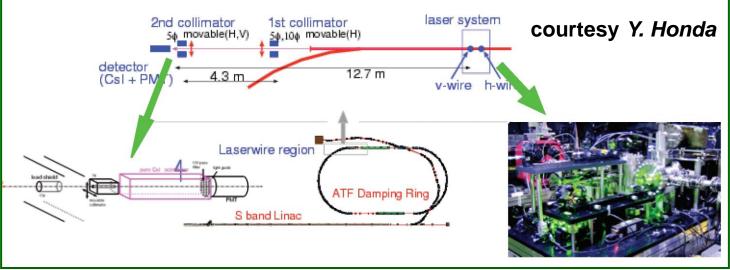
LASER Wire Scanner



Setup

- ATF Damping ring
 - 5 micron (Y), 100 micron (X), typical beam size.
 - horizontal and vertical cavity
 - scan by mover table.
- detection
 - Csl scintillator, counting.
 - Compton edge is 28 MeV.





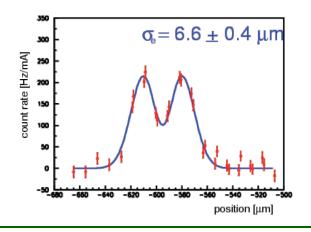
LASER Wire with Optical Cavity

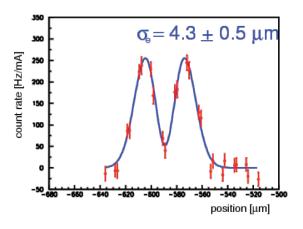


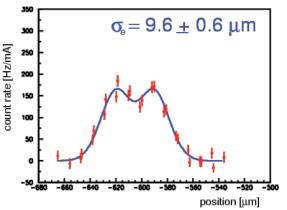
Measurement with a higher-order laserwire

courtesy Y. Honda

- Test to demonstrate higher-mode measurement.
 - laser size was increased on purpose to be optimized to the typical beam size at ATF.
- Fitting free parameter: laser size, beam size, height, center.
- Laser size is 9.6 um (rms), cavity was replaced.
- TEM00 mode only
 - 4.2 um was measured with 5.6 um laser.
- TEM01 mode
 - 4.3 um was measured with 9.6 um laser.









Final Remarks



Missing in this presentation:

- Analog & digital signal processing, trigger & clock signals (subpicosecond), ADC & FPGA technology, clock distribution, etc.
- Programming techniques, system integration, instrument control.
- Calibration methods
- Beam loss monitors and machine protection system
- Feedback system stee Africa ILC instrumentation R&D req
 - Test facility accelerators, e.g. FLASH, ATF, ESA, A0, NML,...
 - International collaboration groups on specific R&D projects.
- Toward the EDR
 - Collect information (email addresses, documents, status quo)
 - Identify uncovered R&D areas, ILC instrumentation requirements.
 - Defining next R&D steps, NML instrumentation,...